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17410 U.S. PTO  
10/612394  
07/03/03

**MAIL STOP PATENT APPLICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: Application of Hironori ENDO  
LIQUID EJECTION CONTROL METHOD AND LIQUID EJECTION  
APPARATUS  
Assignee: **SEIKO EPSON CORPORATION**  
Our Ref. Q76423

Dear Sir:

Attached hereto is the application identified above comprising forty-six (46) sheets of the specification (Japanese Language), including the claims and abstract and twelve (12) sheets of drawings. **The requisite U.S. Government filing fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.**

The Government filing fee is calculated as follows:

Total claims	$\frac{19}{1} - \frac{20}{3}$	$=$	$\frac{\quad}{\quad}$	$\times$	\$18.00	$=$	\$0.00
Independent claims	$\frac{1}{1} - \frac{3}{3}$	$=$	$\frac{\quad}{\quad}$	$\times$	\$84.00	$=$	\$0.00
Base Fee							\$750.00

**TOTAL FEE**



SUGHRUE MION, PLLC

**MAIL STOP PATENT APPLICATION**

Attorney Docket No. **Q76423**

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
<b>Japan</b>	<b>2002-197598</b>	<b>July 5, 2002</b>
<b>Japan</b>	<b>2002-286930</b>	<b>September 30, 2002</b>

The priority documents are enclosed herewith.

Respectfully submitted,  
SUGHRUE MION, PLLC

Attorneys for Applicant

By: *Darryl Mexic*  
Darryl Mexic  
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WASHINGTON OFFICE



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PATENT TRADEMARK OFFICE